

Electronic Patent Application Fee Transmittal

Application Number:	10524814			
Filing Date:	05-May-2006			
Title of Invention:	Atomic layer deposition of high-k metal oxides			
First Named Inventor/Applicant Name:	Sang-In Lee			
Filer:	Maria S. Swiatek/Virginia Rease-Arana			
Attorney Docket Number:	A-71720/MSS (463035-813)			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1110	1110

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				1110